



FRW

PATENT
Customer No. 22,852
Attorney Docket No. 04329.3238

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Gaku MINAMIHABA et al.) Group Art Unit: 2818
)
Application No. 10/771,060) Examiner: Goodwin, David J.
)
Filed: February 4, 2004) Confirmation No. 2231
)
For: POLISHING PAD AND METHOD)
OF MANUFACTURING)
SEMICONDUCTOR DEVICES)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

REQUEST FOR RECONSIDERATION

In reply to the Office Action mailed November 14, 2005, with a period for response extending through February 14, 2006, Applicants request the Examiner's reconsideration in view of the remarks beginning at page 2 of this paper. Applicants are also submitting an information disclosure statement (IDS) concurrently herewith.